

Application/Control No.	No. Applicant(s)/Patent under Reexamination	
10/666,796	CHEN ET AL.	
Examiner	Art Unit	
Michael Misiaszek	3625	

SEARCHED					
Class	Subclass	Date	Examiner		
705	26,27	12/26/2007	MAM		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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EAST Search 7/7/2007 Search updated	12/26/2007	MAM